



2826

Serial No.: 10/044,493

PATENT

CERTIFICATE OF MAILING (37 C.F.R. 1.8a)		
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Box Non-Fee Amendment, Commissioner for Patents, U.S. Patent and Trademark Office, Washington, D.C. 20231.		
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Bin Yu, et al.

Serial No.: 10/044,493

Art Unit: 2826

Filed: January 11, 2002

Confirmation No.: 9266

Title: SEMICONDUCTOR DEVICE WITH SILICIDE
SOURCE/DRAIN AND HIGH-K DIELECTRIC

Examiner: Kevin V. Quinto

Docket No.: G0615

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RESPONSE TO OFFICE ACTION DATED AUGUST 1, 2002

Attn: Box Non-Fee Amendment
Commissioner for Patents
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Sir:

In response to the Office action dated August 1, 2002, the following amendments and remarks are respectfully submitted in connection with the above-identified application. Favorable reconsideration of the subject application is respectfully requested.